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(Rev. 8-83)U.S. Department of Commerce
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Atty Docket 0753-1553

Serial No. 08/698,204

INFORMATION DISCLOSURE STATEMENT

Applicants: Toshimitsu KONUMA et al.

Filing Date: August 14, 1996

Group Art Unit: 2871

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
W	4-133029	05/07/1992	Japan			Abst.
J	5-203977	08/13/1993	Japan			Abst.

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
	English translation of Japanese Patent Office Communication, dated 11/16/1999, 2 pages.

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Examiner	Parker	Date Considered	7/2/00
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Submitted with IDS filed 05/16/00

Sheet 1 of 1

Form PTO-1449 (Rev. 8-83)	U.S. Department of Commerce Patent and Trademark Office	Atty.Docket No. 0756-1553	Serial No. 08/698,204
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant Toshimitsu KONUMA et al.	
		Filing Date August 14, 1996	Group 2871

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
✓		3,600,061	08/17/71	Heilmeier et al.			
✓		4,362,771	12/07/82	Umeda et al.			
✓		4,394,067	07/19/83	Spruijt et al.			
✓		4,826,297	05/02/89	Kubo et al.			
✓		5,130,832	07/14/92	Kawaguchi et al.			
✓		5,247,375	09/93	Mochizuki et al.			
✓		5,278,685	01/11/94	Iwamoto et al.			
✓		5,436,744	07/25/95	Arledge et al.			
✓		5,442,470	08/15/95	Hashimoto			
✓		5,460,983	10/24/95	Hodges et al.			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes No
✓		1-68725	03/89	Japan			Abst.
✓		4-78819	03/92	Japan			X
✓		4-116623	04/92	Japan			X
✓		6-186579	07/01/99	Japan			Abst.
✓		6-186580	07/94	Japan			Abst.

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

✓		Panel Assembling Technique Scriber/Cell Breaking Device: JKL-454F", 93 Latest Liquid Crystal Process Techniques, Semiconductor World, October 1, 1992, p. 272 (with English translation)

Examiner *Quny* Date Considered *7/2/00*

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